



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

March 25, 2026	
IGI Report Number	LG784682107
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	6.42 - 6.46 X 4.04 MM

GRADING RESULTS

Carat Weight	1.04 CARAT
Color Grade	F
Clarity Grade	VVS 2
Cut Grade	EXCELLENT

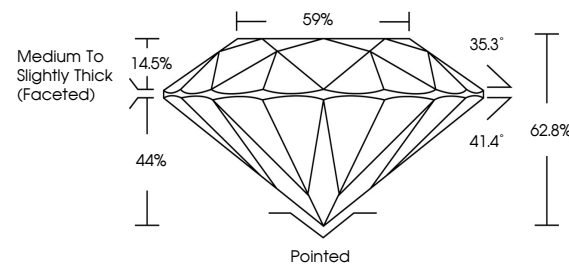
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG784682107

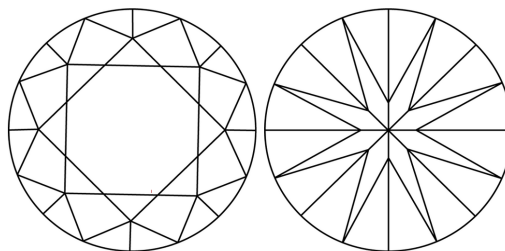
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG784682107
Report verification at igi.org

PROPORTIONS

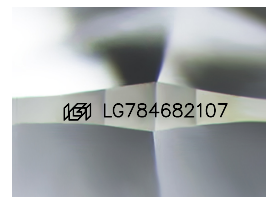


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

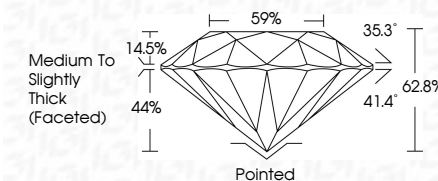
FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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www.igi.org

	VVS 2	Patched
	EXCELLENT	EXCELLENT
	62.8%	NONE
	59%	#G1 LG764682107
	Medium to slightly Thick (Feathered)	
	Culet	
	Polish	Symmetry
	Fluorescence	Inscriptions(s)

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(CVD) growth process.
Type IIG